

6th Semester		Micro Electronic Mechanical Systems	L-T-P 3-0-0	3 CREDITS
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Course Outcome:

- Students will explain MEMS Technology, Present, Future and Challenges.
- Students will be able to explain micro sensors, micro actuators, their type and application

Module-I:**(12 hours)**

Introduction and Emergence of MEMS, Scaling issues, materials for MEMS, Thin film deposition, Photolithography, doping, wet and dry etching
 Micromachining Techniques: Surface and Bulk micro machining, wafer bonding, surface micro machining and LIGA process, Silicon as material for micromachining, (Chapter 3 and Section 8.2 of Book 1, Chapter 2 of Book 2)

Module-II:**(12 hours)**

MEMS devices, Engineering Mechanics for Micro System Modeling and Design – static bending of thin plates, Mechanical vibrational analysis, Thermo mechanical analysis, fracture mechanics analysis, thin film mechanics, Mechanics of deformable bodies, Energy method, Estimation of stiffness and damping for different micro-structures, Modeling of electromechanical systems, Pull-in voltage, Theory and design: Micro Pressure Sensor, micro accelerometer – capacitive and piezoresistive, micro actuator. (Section 4.1 to 4.3 and 6.2.2 of Book 1, Section 3.4 of Book 2)

Module-III:**(12 hours)**

MEMS Applications: Mechanical sensors and actuators: Piezoresistive pressure sensors, MEMS capacitive accelerometer, Optical Gyroscopes: Micro-lens, Micro-mirror, Optical Switch Radiofrequency MEMS: Inductor, Varactor, Filter, Resonator.
 Microfluidics: Capillary action, Micro pumping, Electro wetting, Lab-on-a-chip.
 Electronic interfaces, design, simulation and layout of MEMS devices using CAD tools. (Section 10.1 to 10.8 of Book 2)

Books:

- [1] G.K. Ananthuresh, K.J. Vinoy, S. Gopalakrishnan, K.N. Bhat and V.K. Atre: Micro and Smart Systems, Wiley India, New Delhi, 2010.
- [2] N.P. Mahalik: MEMS, Tata McGraw-Hill, New Delhi, 2007.
- [3] T. Hsu: MEMS and Microsystems: Design and Manufacture, Tata McGraw-Hill, New Delhi, 2002.
- [4] Gabriel M. Rebeiz: RF MEMS Theory, design & Technology, Wiley India Education, 2010.

Digital Learning Resources:

Course Name: MEMS and Microsystems
 Course Link: <https://nptel.ac.in/courses/117/105/117105082/>